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Amorphous Transparent Conducting Oxides (TCOs) Deposited at T 100 ≤ °C

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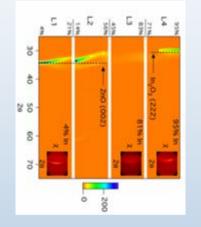


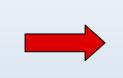
In-Zn-O (IZO), an Amorphous Mixed Metal Oxide Transparent Conductor

- Low Temperature Deposition ($T_S \le 100 \text{ °C}$)
- Smooth ($R_{RMS} < 0.5 \text{ nm}$)
- Thermally Resilient
- Good Conductivity ($\sigma \approx 3000 \ \Omega^{-1} cm^{-1}$)
- High Mobility for Amorphous material ($\mu \approx 30 \text{ cm}^2/\text{V-s}$)

Combinatorial Approach IZO: 5 - 95 %In with 4 depositions

<u>Compositionally</u> <u>Graded Films</u>







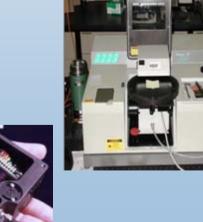
Chemical

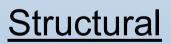








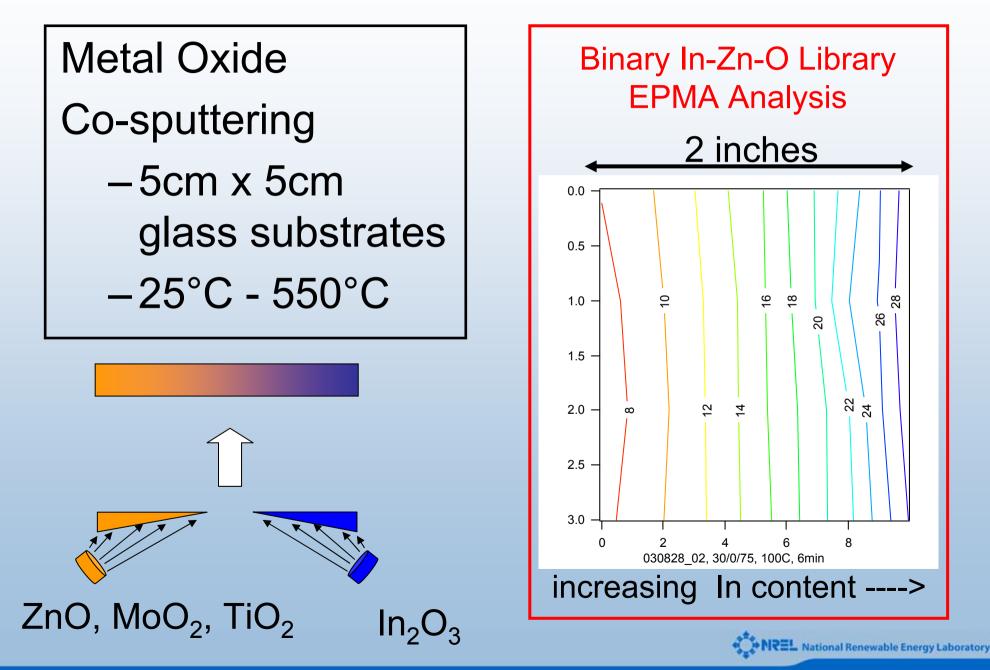




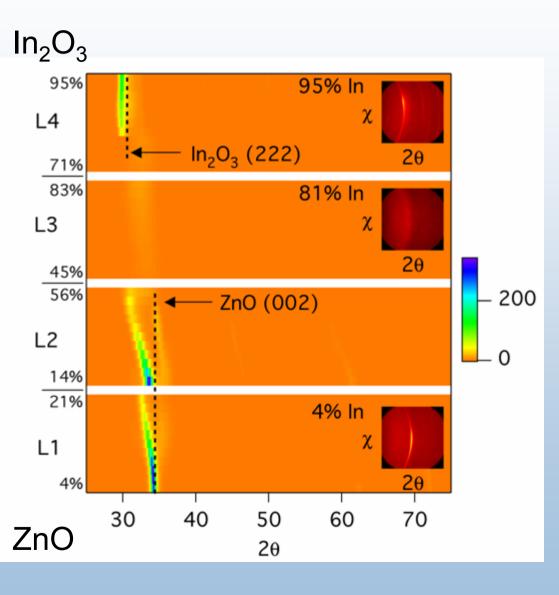


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Film Deposition



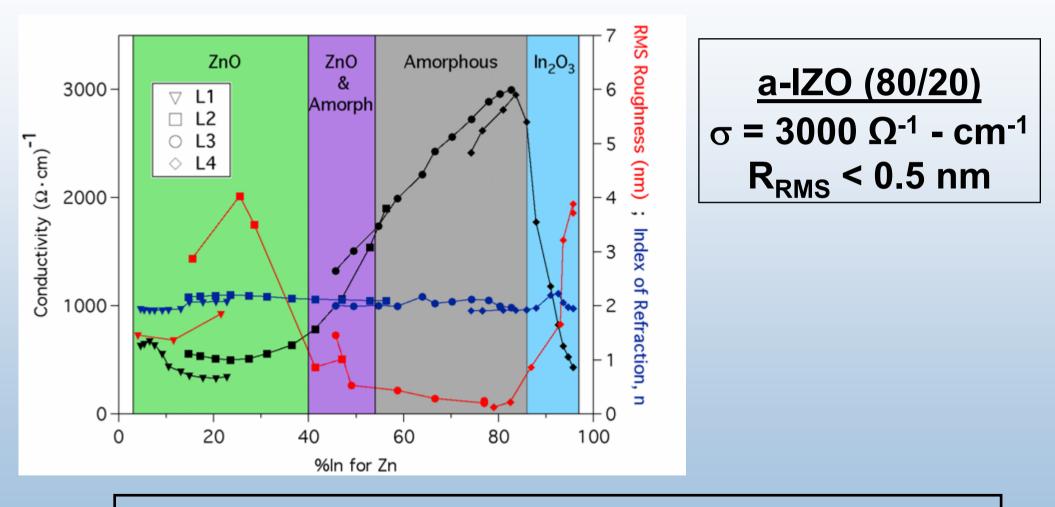
XRD for IZO Deposited at $T_s = 100 \,^{\circ}C$



- Amorphous 55 - 85 % In
- Crystalline Material Textured



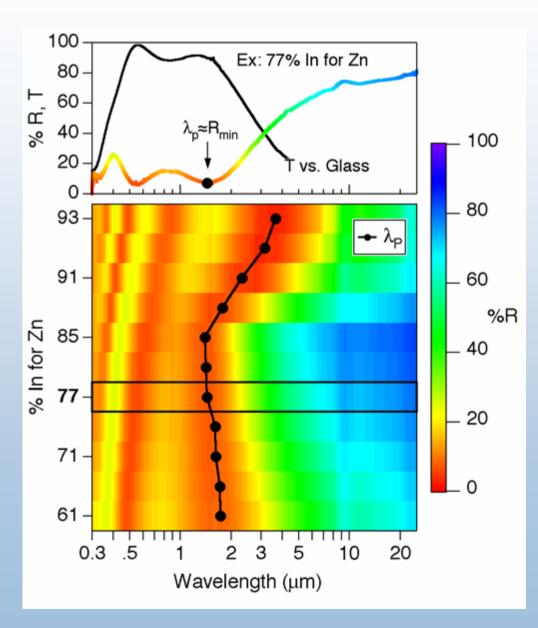
As-dep IZO: Conductivity, Structure, Roughness & Refractive Index



Conductivity maximum occurs in smooth amorphous region.



As-deposited IZO Optical Properties



- Typical TCO (R, T)
- Fringes give thickness
- λ_p changes with %In
- Conductivity tracks λ_p .
 - $\sigma = Ne\mu$

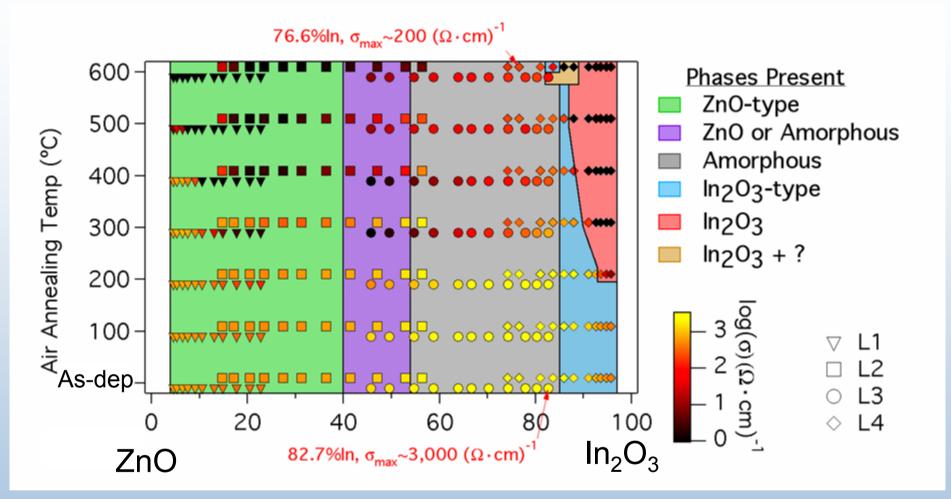
$$\lambda_p \propto 1/\sqrt{N}$$

Annealing of IZO Libraries

- Libraries annealed for 1 hour at target temperature
- Electrical, optical and structural properties evaluated
- Process repeated
 - 1 set of libraries annealed in <u>air</u>
 - 1 set of libraries annealed in argon



IZO Annealed in Air



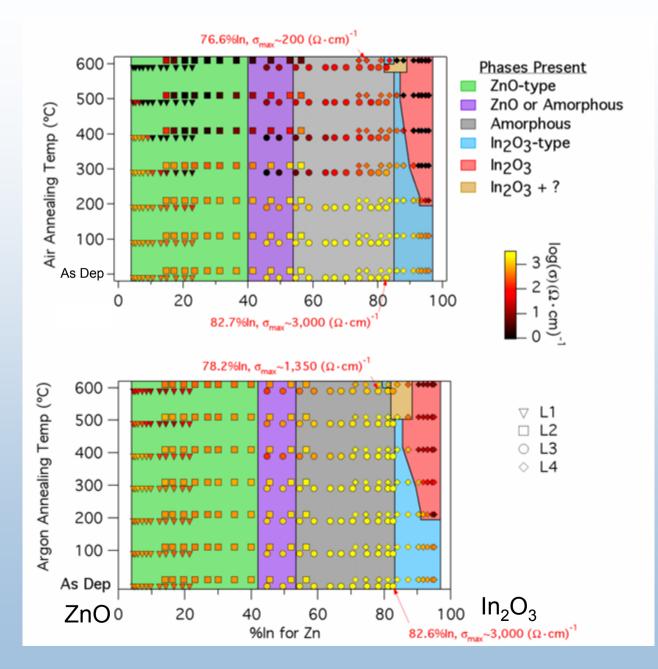
- Amorphous IZO generally does not recrystallize for up to 1 hr @ 600 °C
- Conductivity drop for air-annealed a- IZO 80/20 much less than crystalline material.

Conductivity Drops Less for Argon Anneals

Air Anneal Final Anneal: $\sigma_{max} \sim 200 \ (\Omega \cdot cm)^{-1}$ $\sigma_{min} \sim 0.04 \ (\Omega \cdot cm)^{-1}$

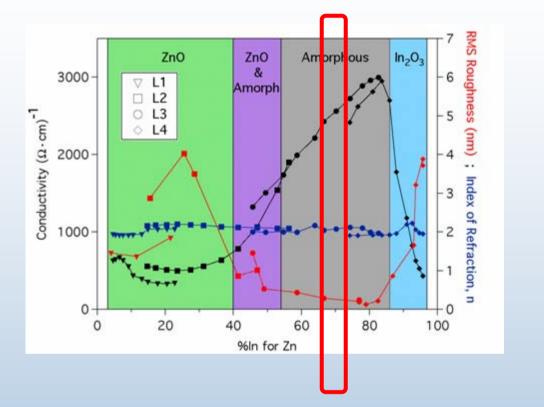
Argon Anneal

Final Anneal: $\sigma_{max} \sim 1,350 \ (\Omega \cdot cm)^{-1.1}$ $\sigma_{min} \sim 6 \ (\Omega \cdot cm)^{-1}$

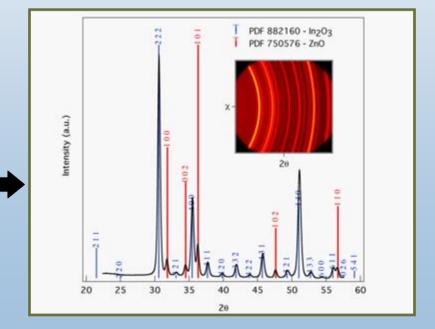




IZO 70/30: Center of Amorphous Region

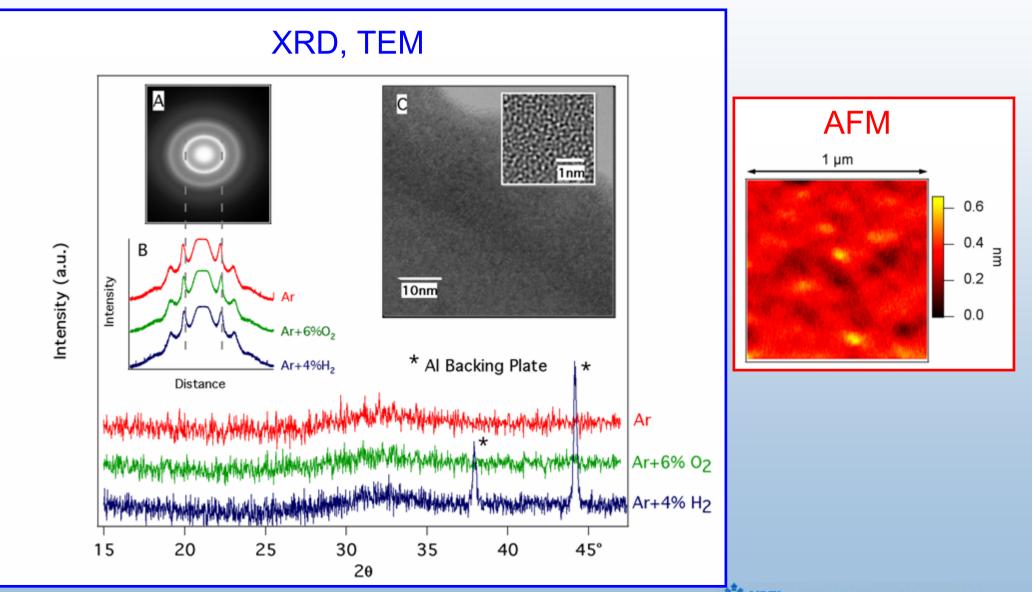


- 2" Single Composition Target
 - Pressed at 25,000psi
 - Sintered in air 800°C, 24hrs
 - Two Phases: ZnO, In₂O₃

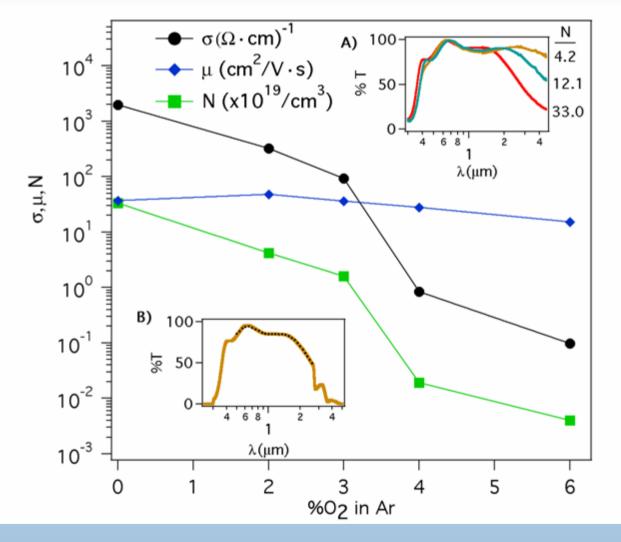




RT Sputtered IZO 70/30 is Amorphous and Smooth



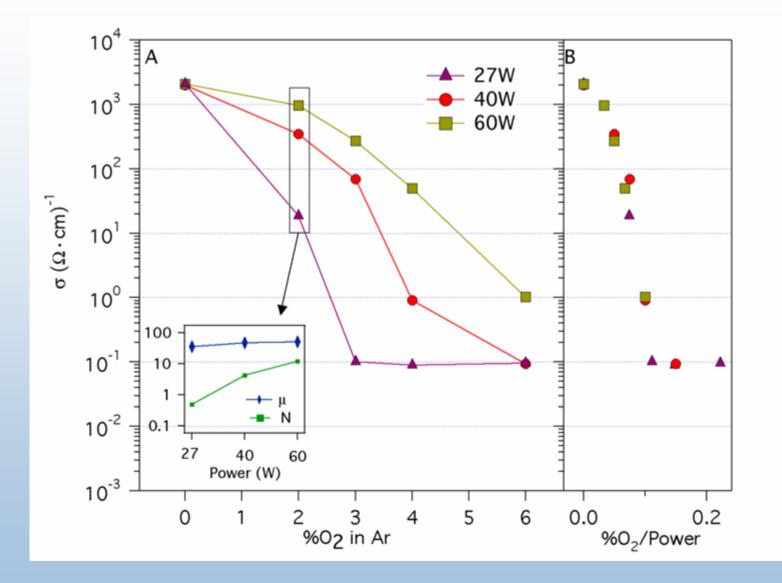
O₂ in Sputter Gas Reduces Conductivity



- N strongly effected by O₂
- µ nearly constant
- µ ≈ 30 cm²/V-s



Effect of O₂ Scales with Sputter Rate





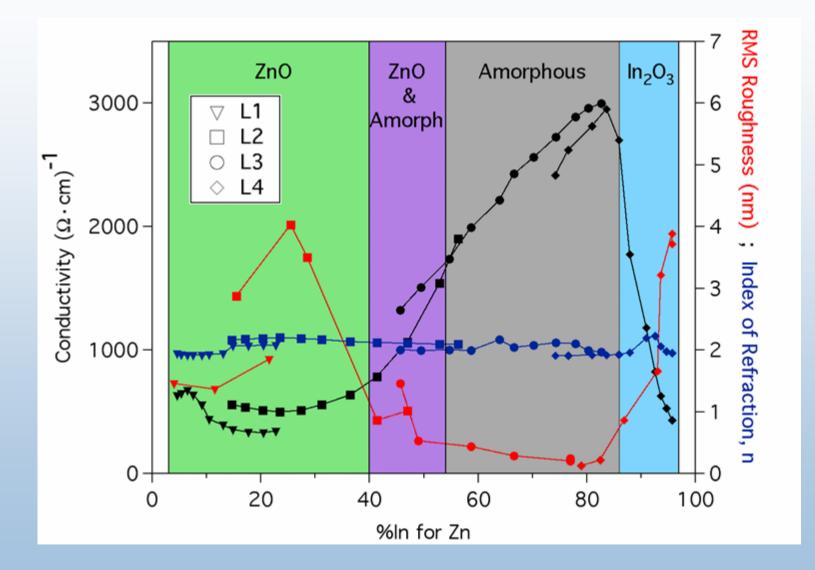
Summary

•Amorphous InZnO (a-IZO) is a very versatile TCO with:

- Low process temperatures (~ 100 °C)
- Easy to make by sputtering
- Excellent optical and electronic properties
- Very smooth etchable films
- Remarkable thermal processing stability

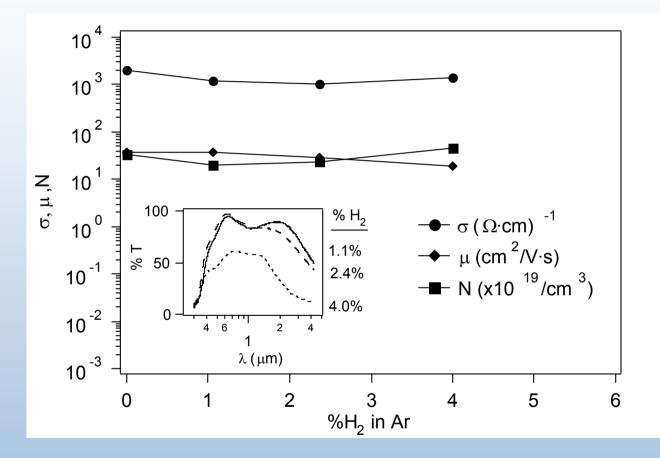


In-Zn-O (IZO): as-dep @ T_s = 100 °C





IZO: H₂ in Sputter Gas



- Overall, mot much effect
- No increase in carrier concentration (N)
- Sample gray for 4% H₂

